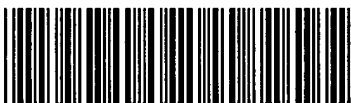


Search Notes

Application/Control No.

10/623,570

Examiner

Hai L. Nguyen

Applicant(s)/Patent under
Reexamination

KIM, JUNG-HOON

Art Unit

2816

SEARCHED

Class	Subclass	Date	Examiner
327	99,152, 158,162, 163	1/28/2005	HLN
327	291-299	1/28/2005	HLN
331	49	1/28/2005	HLN
326	93-98	1/28/2005	HLN

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
Search	Above	1/29/2005	HLN

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Shepardize Search	1/29/2005	HLN
EAST Text Search	1/29/2005	HLN